



INTERNATIONAL  
GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 14, 2026

IGI Report Number

DESCRIPTION

SHAPE AND CUTTING STYLE

MEASUREMENTS

GRADING RESULTS

POLISH

SYMMETRY

FLUORESCENCE

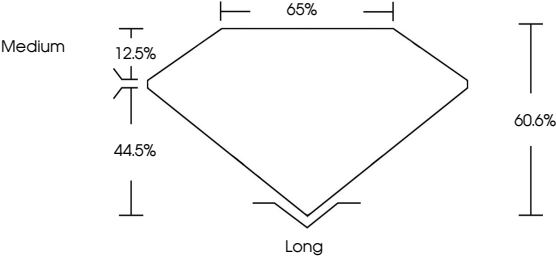
INSCRIPTION(S)

COMMENTS: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

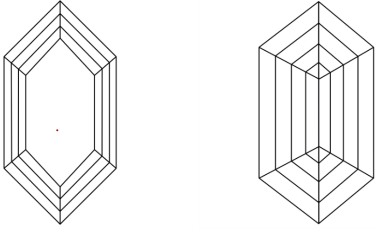
LG816673650

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

CLARITY

Sample Image Used



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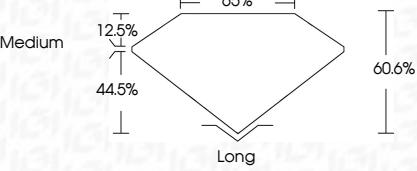
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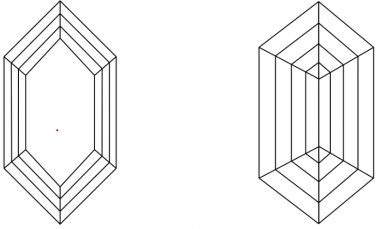
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IGI Report No LG816673650

HEXAGONAL MODIFIED STEP CUT

11.01 X 6.32 X 3.83 MM

2.09 CARATS

D

VVS 1

EXCELLENT

EXCELLENT

NONE

IGI LG816673650

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

IGI



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July 14, 2026

IGI Report No LG816673650

HEXAGONAL MODIFIED STEP CUT

11.01 X 6.32 X 3.83 MM

2.09 CARATS

D

VVS 1

60.6%

65%

Medium

Long

EXCELLENT

EXCELLENT

NONE

IGI LG816673650

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